



2877 / 41  
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Akira HAMAMATSU *et al.*  
Appl'n No. : 10/050,776  
Filed : 18 January 2002  
For : APPARATUS AND METHOD FOR INSPECTING DEFECTS  
Art Unit : 2877  
Examiner : M.P. Stafira  
Conf. No : 9567

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**AMENDMENT**

**Mail Stop Amendment**

Commissioner for Patents  
POB 1450  
Alexandria, Virginia 22313-1450

5 August 2004

Sir:

In response to the Office Action having a USPTO mailing date of 5 March 2004, Applicant respectfully submits the following amendments and remarks in connection with the above-identified application.

In accordance with the revised format of the manner of making amendments under 37 CFR §1.121 as set forth in the Final Rule effective 30 July 2003, each section of amendment herein begins on a new page, and changes are shown by strike-through (or double brackets where appropriate) and underlining to indicate deletions and additions, respectively. A complete listing of all claims ever presented in the application is given with the current status of each claim, and only the text of all pending and withdrawn claims is presented in full, with those not being amended herein being presented in clean version.